Amendments to the Specification:

Please replace paragraph 7 with the following replacement paragraph.

[0007] According to the measure of the dependent claim 2, the fitting is performed through a least-square minimization operation. This is an effective way of minimizing fitting errors.

Please replace paragraph 8 with the following replacement paragraph.

[0008] According to the measure of the dependent claim 3, the least square minimization operation is performed by solving an equation that describes a shape of a soap film loaded with a pressure field equal to a divergence of a slope vector including the first and second slope information. The inventor had the insight that in this way the surface fitting according to the invention can be expressed in a way similar to describing a shape of a soap film loaded with a pressure field. This enables using known methods for determining such a soap film shape to determine the topography of the surface.

Please replace paragraph 9 with the following replacement paragraph.

[0009] According to the measure of the dependent claim 5, for each point of the grid the first and second slope are measured using deflectometry.

Please replace paragraph 12 with the following replacement paragraph.

[0012] According to the measure of the dependent claim 8, the system includes a measurement unit for measuring for each measurement point of a measurement grid the

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corresponding first and second slope information.

Please replace paragraph 13 with the following replacement paragraph.

[0013] According to the measure of the dependent claim 9, the measuring is performed along non-straight lines; the measurement grid being directly used for the reconstruction. The method and system according to the invention perform a fitting that works as long as a connectivity between measurement points (analogous to the nodes belonging to a finite element in a FEM mesh) can be established. It is not required that the grid is neatly arranged, e.g. that the measurement points in the two directions form an equidistant x, y or r, .phi. grid). No calibration of the measurement grid to a grid used for the reconstruction is required, avoiding the introduction of additional errors.

Please replace paragraph 14 with the following replacement paragraph.

[0014] According to the measure of the dependent claim 10, the measurement unit includes a deflectometry measurement unit.

Please replace paragraph 23 with the following replacement paragraph.

[0023] FIGS. 7A-TF show, the exact slopes, slopes containing noise used to reconstruct the surface, reconstructed surface and error in reconstructed surface.

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